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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Yoshihisa MATSUBARA et al.
Serial No.: 09/840,386
Filed: April 23, 2001
Title: **METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE, AND PROCESSING SYSTEM AND
SEMICONDUCTOR DEVICE**
Examiner: Lan Vinh
Group Art Unit: 1765
Confirmation No.: 2510
Attorney Docket No.: 100806-00199 (NEKA 18.612)

November 28, 2005

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Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

S I R:

In response to the final Office Action issued June 28, 2005, please amend the above-captioned application as follows: